

Notice of References Cited	Application/Control No. 10/648,448		Applicant(s)/Patent Under Reexamination KASHIWAYA ET AL.	
	Examiner Shun Lee		Art Unit 2884	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,891,277 A	01-1990	Nakamura, Takashi	250/484.4
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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